

* NOTICES *

Japan Patent Office is not responsible for any damages caused by the use of this translation.

1. This document has been translated by computer. So the translation may not reflect the original precisely.
2. **** shows the word which can not be translated.
3. In the drawings, any words are not translated.

CLAIMS

[Claim(s)]

[Claim 1] Lay a substrate on a flat table, move a die coating machine relatively to this substrate, and it faces [applying on the above-mentioned substrate, and]. Form a range-measurement machine in the above-mentioned die coating machine, and the real gap of the above-mentioned die coating machine and a substrate is measured beforehand in all application regions. The method of application of the die coating machine characterized by applying making it go up and down the above-mentioned die coating machine to a substrate based on this operation value at the time of an application after calculating the deflection of the above-mentioned real gap and a criteria gap in all these application regions.

[Translation done.]